

# m-OTR application to the RTML at ILC and CLIC

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# Outline

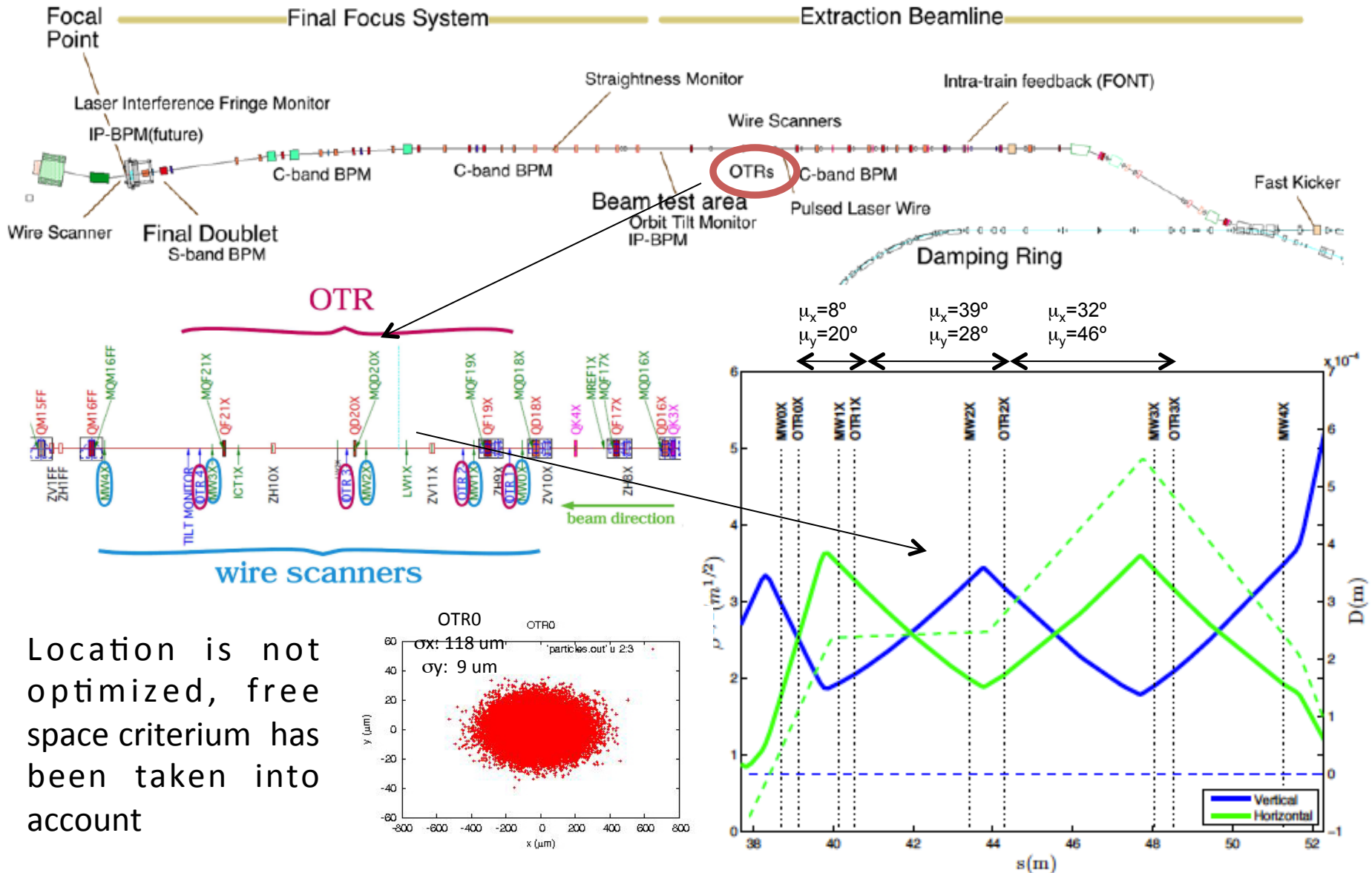
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- Introduction
  - The m-OTR system of ATF2
  - The emittance reconstruction analysis
- Lessons learned and implications to ILC and CLIC
- Figure of merit
- m-OTR system for ILC RTML
- m-OTR system for CLIC RTML
- Conclusions and Future studies

- The multi-OTR system is made of **4 OTRs** installed in the zero-dispersion part of ATF2 EXT line
- The objective of this project is the **fast measurement of the emittance** (single shot for beam size, 1min for emittance) with:
  - high statistics
  - **2 $\mu$ m** resolution
  - **$2 \times 10^{10}$  single bunch** and  **$2 \times 10^{11}$  for 20 multi-bunched** beam (2.8 ns spacing)
- The design is based on OTR1X at ATF EXT line (**5 $\mu$ m resolution with  $2 \times 10^{10}$** ) including improved features (compactness, calibration setup, demagnifier system..)
- The system is **installed near WS** for comparison and confirmation of OTR as a beam emittance diagnostic device

# Introduction

# Location and Optics



Location is not optimized, free space criterium has been taken into account

- **Proposal to ATF2 collaboration** June 2009
- **Design and Construction** Fall 2009
- **Calibration at IFIC and SLAC labs** February 2010
- **Installation in the ATF2 EXT line** April-May 2010
- **First Test with beam** June 2010
- **Test, Software Developments for beam size and emittance reconstruction and implementation in ATF2 control system** Fall 2010
- **New targets, Calibration system and Camera protection system** November 2010
- **Software Developments, Calibration and First Beam Measurements** Nov-Dec 2010
- **New LAN Control system** February 2011
- **Systematic Measurements I (before Tohoku earthquake)** January-March 2011
- **Design and Construction of a Demagnifier system** January-April 2011
- **Installation of the Demagnifier system** August 2011
- **Development of Coupling correction software algorithms** from September 2011
- **Systematic Measurements II (after Tohoku earthquake)** Nov 2011- Dec 2012
- **Proposal of new Target holders and Optical system** September 2012
- **Design and Construction of new Target holders** February-December 2012
- **New Target holder Installation** February 2013
- **Systematic measurements III** from March 2013



## Single OTR panel

The screenshot shows the mOTR\_2 software interface. On the left, several green arrows point to specific sections: 'Working mode & Reference system' (pointing to the Mode & Ref System section), 'Target control' (pointing to the Target section), 'Calibrations' (pointing to the Calibration Settings section), 'Beam finder' (pointing to the Beam Finder section), 'CCD Gain' (pointing to the Gain section), and 'Position & movement of the movers' (pointing to the Fitting Cuts section). The main interface is divided into several panels. The top-left panel contains 'Mode & Ref System' with buttons for 'NonOTR', 'OTR', 'Set current as origin', 'Set default as origin', and 'Change defaults'. The top-right panel is 'Gaussian / Ellipse Fitting' with a table of parameters and a 'Pixels' radio button. The middle-left panel is 'Target' with 'Out' and 'In' buttons and an 'Integration Time (s)' field. The middle-right panel is 'Calibration Settings' with 'Beam Finder' buttons and 'Gain (dB)' and 'Max ADC' fields. The bottom-left panel is 'Fitting Cuts' with 'N' and '% Peak' fields. The bottom-right panel is 'Limit switches status' with 'Y Min', 'Y Max', 'X Min', 'X Max', 'F Min', and 'F Max' buttons. The bottom-most panel shows 'Beam Presence Cut' with a slider and a value of 1743. The right side of the interface features a large 'CCD image and beam fitting' area showing a beam spot with a fitted ellipse. Above the image is a plot of the 'number of measurements' (10) and a 'Machine status' indicator (FS). Below the image are two red status bars: 'Target is IN' and 'OTR mode'. A green arrow points to the 'Machine status' indicator.

Working mode & Reference system

Target control

Calibrations

Beam finder

CCD Gain

Position & movement of the movers

Limit switches status

Ellipse fitting and analysis

Machine status

number of measurements

CCD image and beam fitting

Parameter	Value 1	Value 2
sx	72.0418	0.37007
sy	21.8911	0.21814
sxy	943.6329	14.269
X	294.8829	6.914
Y	184.1296	6.39
projX	97.7062	0.73738
projY	26.3838	0.38082

N	% Peak
3	0.2

Beam Presence Cut
1

## Emittance panel

The screenshot shows the 'emittance' software interface. On the left, there are several green arrows pointing to specific parts of the interface:

- Current OTR info:** Points to the top plot area showing a beam profile.
- Start/stop emittance procedure:** Points to the 'Calc Emittance' and 'Stop' buttons.
- Number of OTR to be used:** Points to the 'OTRs to use' section with checkboxes for OTR0X, OTR1X, OTR2X, and OTR3X.
- Data analysis and plots:** Points to the 'Projected Emittance Data Plots' and 'Ellipse Emittance Data Plots' buttons.
- Automatic Coupling correction:** Points to the 'Correct Coupling' button.
- number of measurements per OTR:** Points to the '# Pulses Per OTR' input field, which is set to 10.
- Calculation data:** Points to the 'Status / Calculation Data' section on the right, which displays various parameters.

The 'Status / Calculation Data' section contains the following information:

Setting OTR3X to Non-Measurement position  
Horizontal projected emittance parameters at first OTR

energy	=	1.2818	GeV
emit	=	2657.5641 +- 30.5584	pm
emita	=	6666.1197 +- 76.6515	nm
emita*bmag	=	9625.1319 +- 213.3261	nm
bmag	=	1.4439 +- 0.0285	( 1.0000)
bmag_cos	=	-0.2306 +- 0.0000	( 0.0000)
bmag_sin	=	0.6835 +- 0.0000	( 0.0000)
beta	=	7.0400 +- 0.0925	m ( 6.3369)
alpha	=	-4.0462 +- 0.0523	( -4.5304)
chisq/N	=	58.5405	

Vertical projected emittance parameters at first OTR

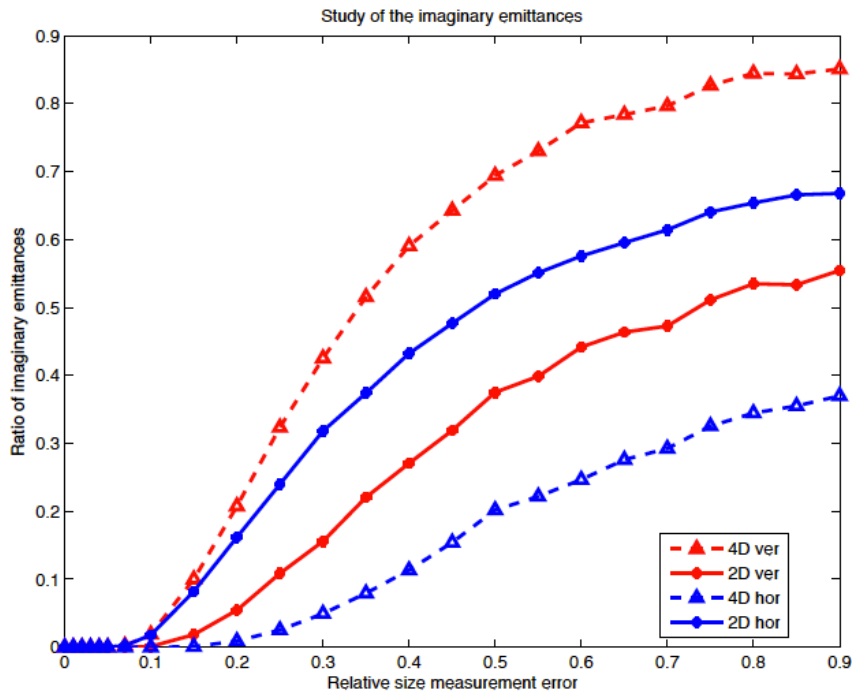
energy	=	1.2818	GeV
emit	=	41.3816 +- 0.8088	pm
emita	=	103.7999 +- 2.0289	nm
emita*bmag	=	148.3472 +- 1.6256	nm
bmag	=	1.4292 +- 0.0241	( 1.0000)
bmag_cos	=	0.5561 +- 0.0000	( 0.0000)
bmag_sin	=	0.4485 +- 0.0000	( 0.0000)
beta	=	14.1804 +- 0.3257	m ( 6.3764)
alpha	=	6.7081 +- 0.1588	( 2.7261)
chisq/N	=	654.6296	

Horizontal ellipse emittance parameters at first OTR

energy	=	1.2818	GeV
emit	=	2159.2778 +- 9.3504	pm
emita	=	5416.2397 +- 23.4541	nm
emita*bmag	=	9756.6252 +- 24.9513	nm
bmag	=	1.8014 +- 0.0086	( 1.0000)



The **emittances** could be reconstructed from the **beam size measurements** at different locations along the beamline. The **2D** (transverse) and **4D** (intrinsic) emittances could be obtained by **solving numerically three separated systems** of coupled equations. When the number of measurement stations is greater than four, these **systems are overdetermined**, and the numerical solutions can lead to unphysical results. The incidence of such meaningless results usually increases if the measurements are noisy. Numerical rules can be used to study the conditioning of these systems.



The **main objective** of this work is to **study analytically** the conditions of **solvability of these systems of equations** and its implication in the emittance reconstruction algorithms used in the accelerators. The aim is to give some hints about the **optical constrains** and the **location of the measurement stations**.

In the general case of  $N$  measurement stations. The system has **unique solution** ( $\sigma_1 \sigma_2 \sigma_5$ ) if and only if the rank of both  $M_X$  and  $M_X^*$  is equal to three. This give us two conditions:

**Condition1:**  $\phi_x^{(ji)} \neq n\pi, \forall(i, j)$

The **measurement** stations should be **located** at places where the **phase advances** correspond to **different snapshots** of the beam. This is the only required condition in the case of **3** measurement stations.

For **4 or more stations** a second condition is required to get a unique solution.

**Condition 2:**  $-\hat{\sigma}_1^{(i)} \Delta_{3x}(jkl) + \hat{\sigma}_1^{(j)} \Delta_{3x}(ikl) - \hat{\sigma}_1^{(k)} \Delta_{3x}(ijl) + \hat{\sigma}_1^{(l)} \Delta_{3x}(ijk) = 0, \forall(ijkl)$

$$\Delta_{3x}(ijk) = 2\beta_x^{(i)} \beta_x^{(j)} \beta_x^{(k)} \sin\phi_x^{(ji)} \sin\phi_x^{(ki)} \sin\phi_x^{(kj)}$$

$$A_{4x}(ijkl) = -\hat{\sigma}_1^{(i)} \Delta_{3x}(jkl) + \hat{\sigma}_1^{(j)} \Delta_{3x}(ikl) - \hat{\sigma}_1^{(k)} \Delta_{3x}(ijl) + \hat{\sigma}_1^{(l)} \Delta_{3x}(ijk)$$

Condition 2 involve the  $\beta$  and the **measurements**, one can see that **in general** the equality **cannot be exactly satisfied**. One could replace the **zero** by some previously **fixed error value**, related with the error of the **measurements**.

**Idem for vertical plane.**

In the general case of  $N$  measurement stations we have  $M_{XY}$  and  $M_{XY}^*$ , the system has **unique solution**  $(\sigma_3 \sigma_4 \sigma_6 \sigma_7)$  if and only if the rank of both  $M_{XY}$  and  $M_{XY}^*$  is equal to four. This give us two more conditions:

### Condition 3:

$$\begin{aligned} & \cos(\varphi_x^{(ji)} + \varphi_x^{(lk)}) [\cos(\varphi_y^{(ki)} + \varphi_y^{(lj)}) - \cos(\varphi_y^{(ki)} - \varphi_y^{(lj)})] \\ & + \cos(\varphi_x^{(ki)} + \varphi_x^{(lj)}) [\cos(\varphi_y^{(ji)} - \varphi_y^{(lk)}) - \cos(\varphi_y^{(ji)} + \varphi_y^{(lk)})] \\ & + \cos(\varphi_x^{(ji)} - \varphi_x^{(lk)}) [\cos(\varphi_y^{(ji)} + \varphi_y^{(lk)}) - \cos(\varphi_y^{(ki)} + \varphi_y^{(lj)})] \neq 0, \forall (ijkl) \end{aligned}$$

This is the only required condition in the case of **4** measurement stations. In the particular case where  $\phi_x^{(ji)} = \phi_y^{(ji)}$  the system has **no solution**.

For **5 or more stations** an additional condition is required to get a **unique solution**.

### Condition 4:

$$\hat{\sigma}_3^{(i)} \Delta_4(jklm) - \hat{\sigma}_3^{(j)} \Delta_4(iklm) + \hat{\sigma}_3^{(k)} \Delta_4(ijlm) - \hat{\sigma}_3^{(l)} \Delta_4(ijkm) + \hat{\sigma}_3^{(m)} \Delta_4(ijkl) = 0, \forall (ijklm)$$

$$\begin{aligned} & -8(\beta_x^{(i)} \beta_y^{(i)} \beta_x^{(j)} \beta_y^{(j)} \beta_x^{(k)} \beta_y^{(k)} \beta_x^{(l)} \beta_y^{(l)})^{-1/2} \Delta_4(ijkl) = \cos(\varphi_x^{(ji)} + \varphi_x^{(lk)}) [\cos(\varphi_y^{(ki)} + \varphi_y^{(lj)}) - \cos(\varphi_y^{(ki)} - \varphi_y^{(lj)})] \\ & + \cos(\varphi_x^{(ki)} + \varphi_x^{(lj)}) [\cos(\varphi_y^{(ji)} - \varphi_y^{(lk)}) - \cos(\varphi_y^{(ji)} + \varphi_y^{(lk)})] + \cos(\varphi_x^{(ji)} - \varphi_x^{(lk)}) [\cos(\varphi_y^{(ji)} + \varphi_y^{(lk)}) - \cos(\varphi_y^{(ki)} + \varphi_y^{(lj)})] \end{aligned}$$

$$A_5(ijklm) = +\hat{\sigma}_3^{(i)} \Delta_4(jklm) - \hat{\sigma}_3^{(j)} \Delta_4(iklm) + \hat{\sigma}_3^{(k)} \Delta_4(ijlm) - \hat{\sigma}_3^{(l)} \Delta_4(ijkm) + \hat{\sigma}_3^{(m)} \Delta_4(ijkl)$$

One could replace the **zero** by some previously **fixed error value**, related with the error of the **measurements**.

# Lessons learned and Implications for ILC and CLIC

- The **m-OTR system** of the ATF2 EXT has demonstrated its performances as a **fast** (1min) and **reliable** system for measuring the beam size and the emittance. The system is **totally integrated** in the **online model** and it is **crucial** for **tuning procedures** of the beamline as: coupling correction, beta matching, energy spread measurements...Studies to ameliorate these procedures are ongoing
- We have **studied analytically** the **conditions of solvability** of the systems of equations involved in the process of emittance reconstruction and we have obtained some rules about the **locations** of the **measurement stations** to avoid unphysical results. **Simulations** are being made to test the robustness with high coupling scenarios and measurement errors. The results of these studies will be very **useful** to better determine the location of the emittance measurement stations in the **diagnostic sections** of **FLCs**.
- OTR monitors are **mature** and **reliable** diagnostic tools that could be **very suitable** for the setup and tuning of the machine in single-bunch mode. It can be very useful during **start up** and **commissioning** phases of the **RTML**. The **feasibility** of using a m-OTR system in **transfer lines** of the **ILC RTML** as well as a study of the different **materials** for the OTR **target** and possible limitations of operation is presented in the following.

# Figure of merit

In order to adapt a m-OTR system to a linear collider RTML context, the key point is the selection of a suitable material to make the OTR radiator (target) in order to avoid its damage when the beam goes through it.

## Temperature rise in the target per pulse

(assuming target foil thickness < 1 radiation length)

$$\Delta T_{inst} = \frac{1}{\rho C_p} \left( \frac{dE}{dz} \right) \frac{N_b N_e}{2\pi \sigma_x \sigma_y}$$

$\rho$ : material density  
 $C_p$ : specific heat  
 $N_b$ : number of bunches per pulse ( $N_b=1$ , single-bunch operation)  
 $N_e$ : number of particles per bunch  
 $(dE/dz)$ : collision stopping power (Bethe-Bloch formula)

compare



$$\Delta T_{fr} \cong \frac{2\sigma_{UTS}}{\alpha_T Y}$$

$\sigma_{UTS}$ : ultimate tensile stress  
 $\alpha_T$ : thermal expansion coefficient  
 $Y$ : Young modulus

Condition:

$$\Delta T_{inst} < \Delta T_{fr}$$

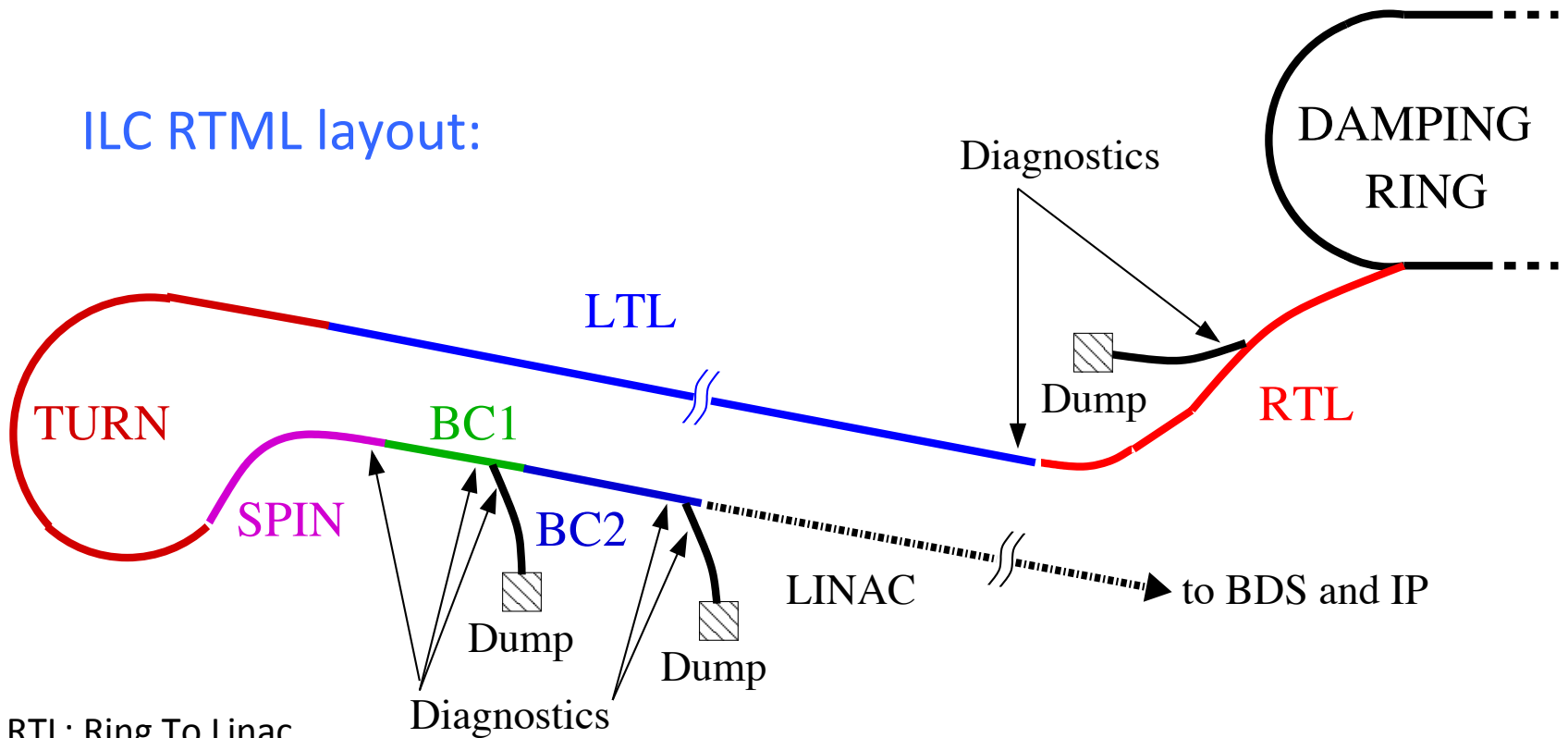
$$\Delta T_{inst} < (T_{melt} - 293 \text{ K})$$

## Mechanical and thermal properties of various materials

Property	Kapton*	Al	Be	Ti	W
$\sigma_{UTS}$ [MPa]	231	50	370	220	980
$Y$ [ $\times 10^5$ MPa]	0.025	0.68	2.87	1.16	4.11
$\alpha_T$ [ $\times 10^{-6}$ K $^{-1}$ ]	20	23.1	11.6	8.6	4.5
$k$ [W/(mK)]	0.12	210	200	17	163
$C_p$ [J/(gK)]	1.09	0.91	1.925	0.528	0.134
$T_{melt}$ [K]	–	933.37	1546	1923	3643

\*Kapton does not melt, but decomposes at 793 K

# Multi-OTR System for ILC RTML



RTL: Ring To Linac

LTL: Long Transfer Line

TURN: Turnaround

SPIN: Spin Rotator

BC1: First Bunch Compressor

BC2 : Second Bunch Compressor

Here we study the following cases:

- Assuming m-OTR system at the beginning of the LTL
- At the end of the RTML (end of BC2)

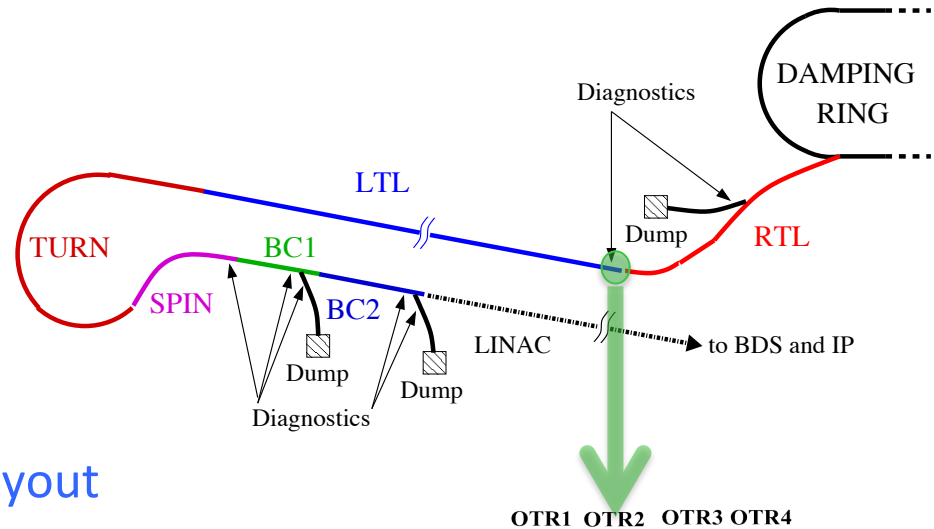
# Multi-OTR System for ILC RTML

At the beginning of LTL:

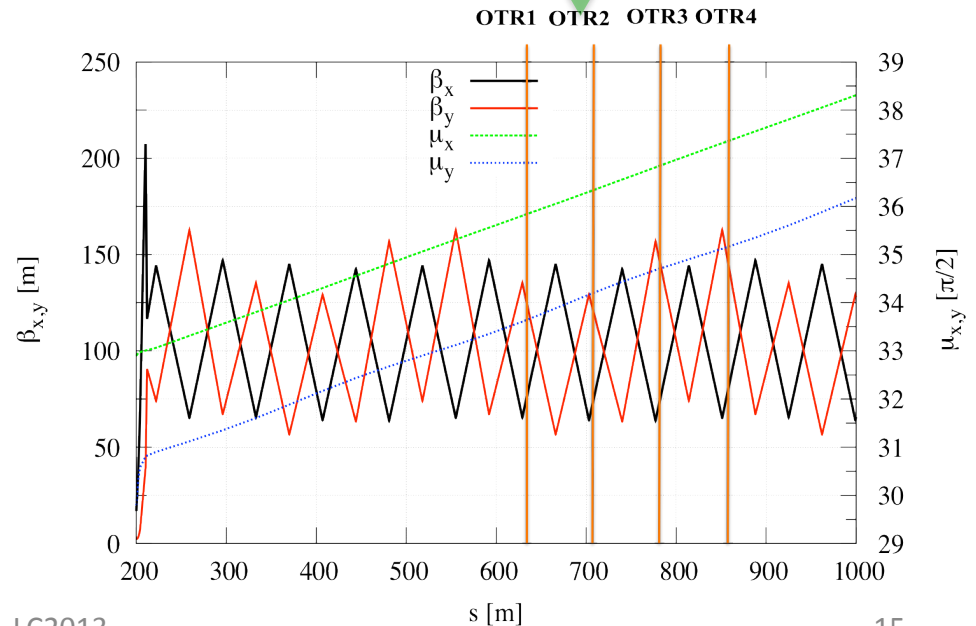
Beam parameters

Parameter	Start RTML
$E$	5 GeV
$N_e$	$2 \times 10^{10}$
$\sigma_z$	6 mm
$\sigma_{\Delta E/E}$	0.13%
$\gamma \varepsilon_x$	8 $\mu\text{m}$
$\gamma \varepsilon_y$	20 nm

Optics layout



- The LTL lattice mainly consists of FODO cells with  $\mu_{x,y} = \pi/4$  phase advance
- For coupling correction, skew quadrupoles can be placed in the FODO cells upstream of this system

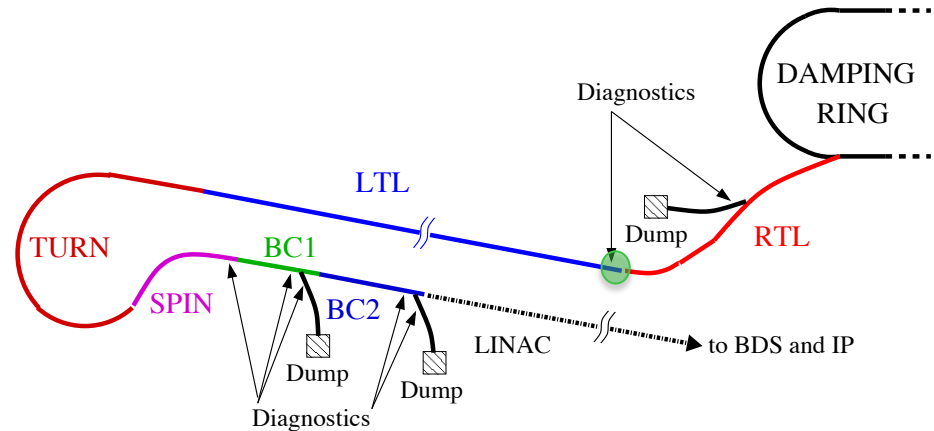


At the beginning of LTL:

$$\sigma_x \approx 239 \mu\text{m} (\beta_x \approx 70 \text{ m})$$

$$\sigma_y \approx 17.5 \mu\text{m} (\beta_y \approx 150 \text{ m})$$

Assuming single bunch operation



Material	$\frac{dE}{dz}$ [MeV/cm]	$\Delta T_{inst}$ [K]	$\Delta T_{fr}$ [K]
Kapton	3.297	25.973	9240
Al	5.778	28.675	63.662
Be	3.704	12.682	222.28
Ti	9.112	46.35	441.06
W	32.366	152.6	1059.7

$\Delta T_{inst}$  below the fracture limit and far below below the temperature excursion for melting ( $T_{melt} - 293 \text{ K}$ ). No damage is expected in this case operating in single bunch mode

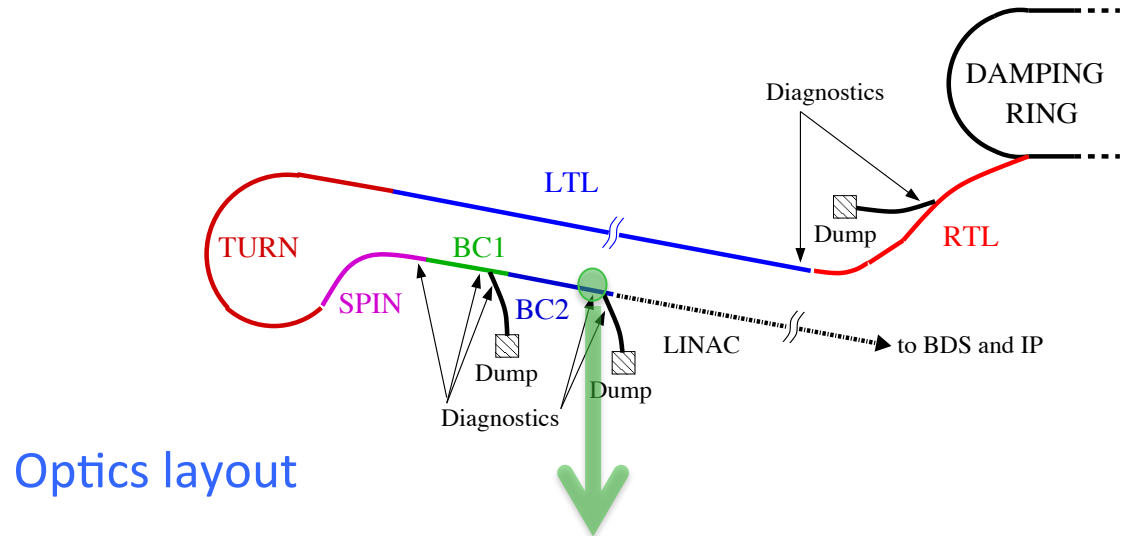


# Multi-OTR System for ILC RTML

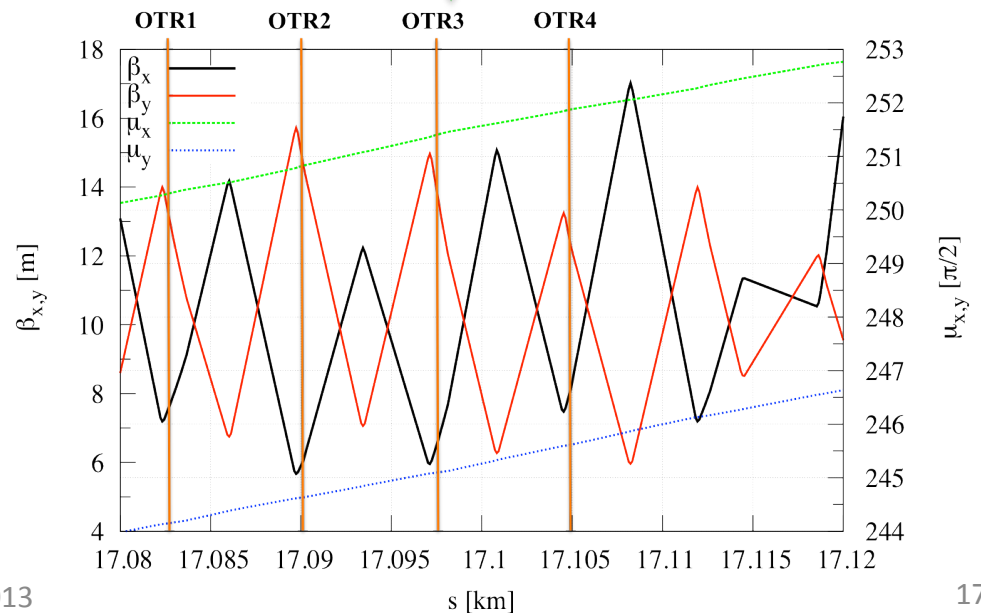
At the end of BC2:

Beam parameters

Parameter	End RTML
E	15 GeV
$N_e$	$2 \times 10^{10}$
$\sigma_z$	0.3/0.15 mm
$\sigma_{\Delta E/E}$	1.07%
$\gamma \epsilon_x$	8 $\mu\text{m}$
$\gamma \epsilon_y$	20 nm



Optics layout

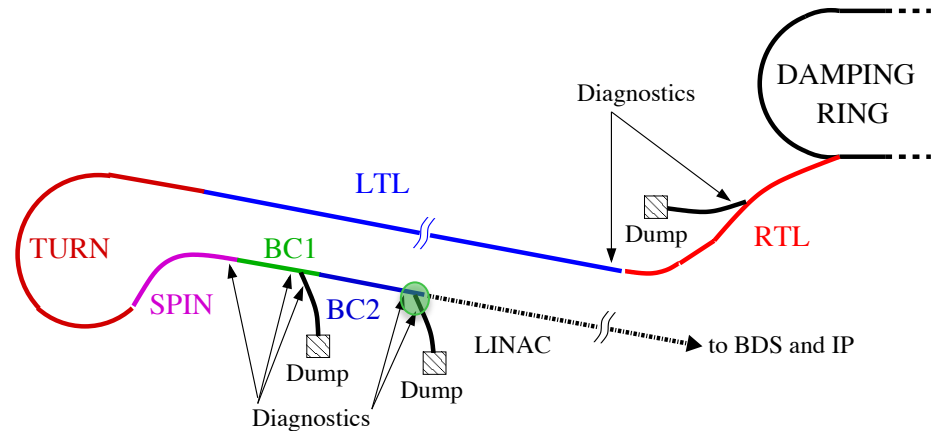


At the end of BC2:

$$\sigma_x \approx 75.6 \mu\text{m} (\beta_x \approx 7 \text{ m})$$

$$\sigma_y \approx 5.3 \mu\text{m} (\beta_y \approx 14 \text{ m})$$

Assuming single bunch operation

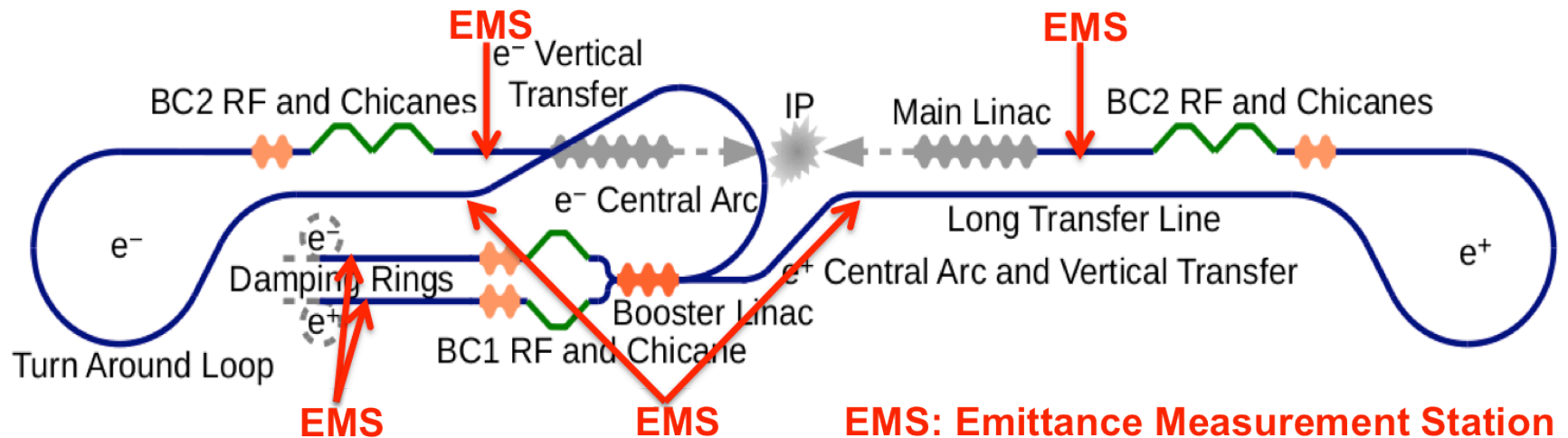


Material	$\frac{dE}{dz}$ [ $\frac{\text{MeV}}{\text{cm}}$ ]	$\Delta T_{inst}$ [K]	$\Delta T_{fr}$ [K]
Kapton	3.665	298.81	9240
Al	5.996	307.96	63.662
Be	3.822	135.43	222.28
Ti	9.386	494.12	441.06
W	33.678	1643.3	1059.7

- In this case stress fractures may be generated for targets made of Al, Ti and W. These calculations indicate that Kapton and Be could avoid damage.
- The use of Be could be discouraged due to its toxicity. Kapton could be a good candidate

# Multi-OTR System for CLIC RTML

## CLIC RTML layout:



We study the following cases:

- Assuming m-OTR system at the beginning of the RTML
- At the end of the RTML (end of BC2)

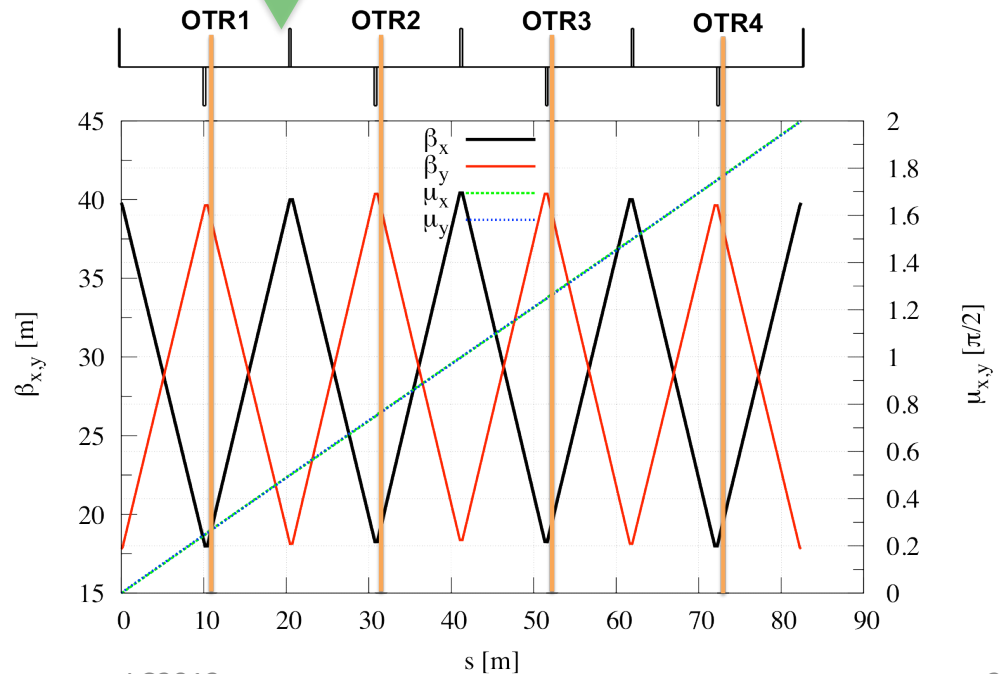
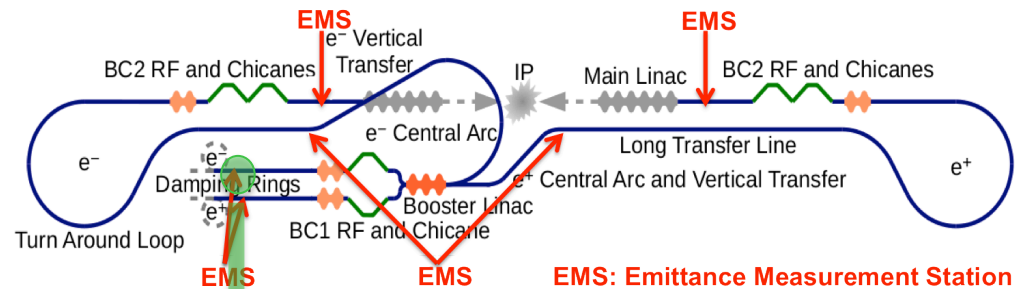
# Multi-OTR System for CLIC RTML

At the beginning of RTML:

Beam parameters

Parameter	Start RTML
E	2.86 GeV
$N_e$	$4 \times 10^9$
$\sigma_z$	1.8 mm
$\sigma_{\Delta E/E}$	0.12%
$\gamma \epsilon_x$	500 nm
$\gamma \epsilon_y$	5 nm

Optics layout  
(2D EMS)

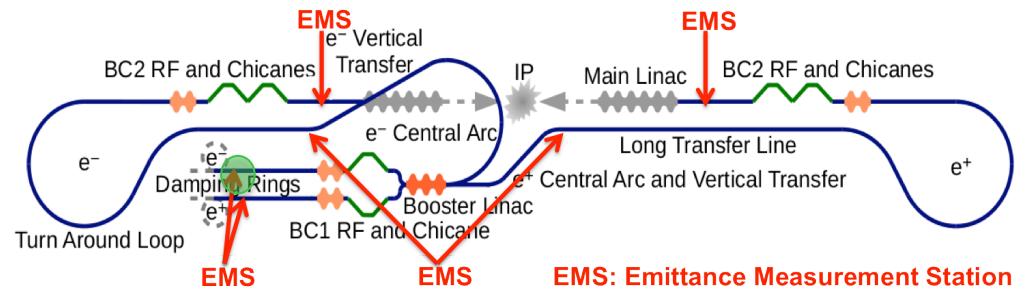


# Multi-OTR System for CLIC RTML OTR target damage study

At the beginning of RTML:

$$\sigma_x \approx 40 \mu\text{m} (\beta_x \approx 17.8 \text{ m})$$

$$\sigma_y \approx 6 \mu\text{m} (\beta_y \approx 39.8 \text{ m})$$



Material	$\frac{dE}{dz}$ [ $\frac{\text{MeV}}{\text{cm}}$ ]	$\Delta T_{inst}$ [K]	$\Delta T_{fr}$ [K]
Kapton	3.235	90.931	9240
Al	5.665	100.31	63.662
Be	3.633	44.383	222.28
Ti	8.935	162.17	441.06
W	31.691	533.12	1059.7

Kapton, Be, Ti and W are below the fracture limit and Al surpasses such limit

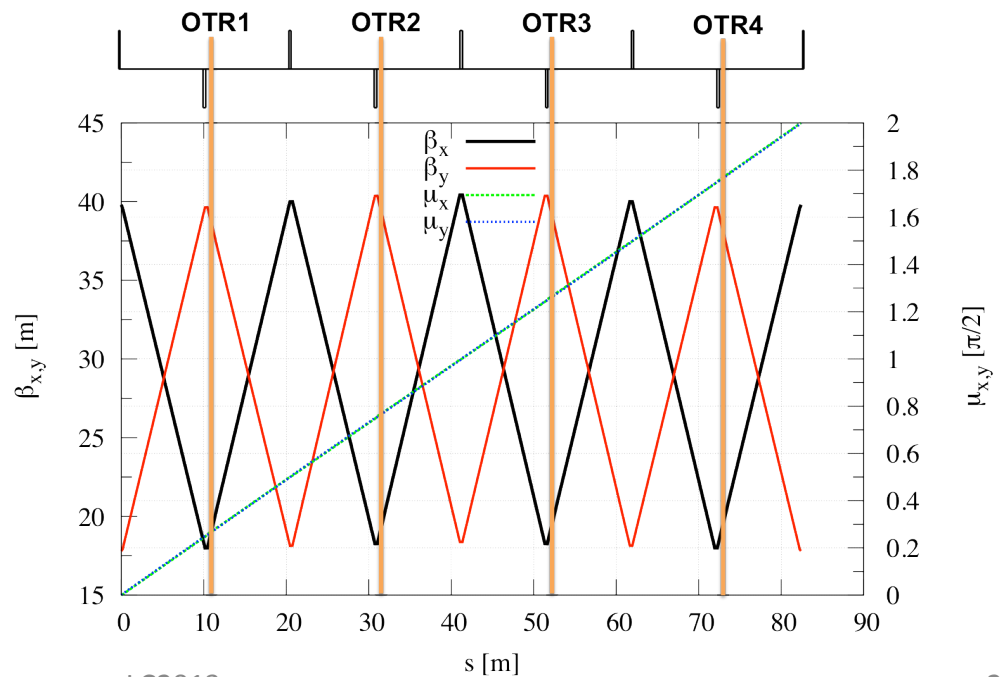
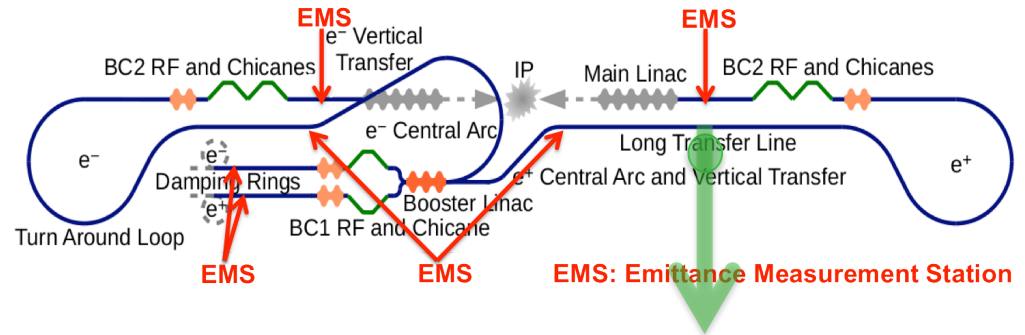
# Multi-OTR System for CLIC RTML

At the end of RTML:

Beam parameters

Parameter	End RTML
$E$	9 GeV
$N_e$	$3.72 \times 10^9$
$\sigma_z$	44 $\mu\text{m}$
$\sigma_{\Delta E/E}$	< 1.7%
$\gamma \epsilon_x$	< 600 nm
$\gamma \epsilon_y$	< 10 nm

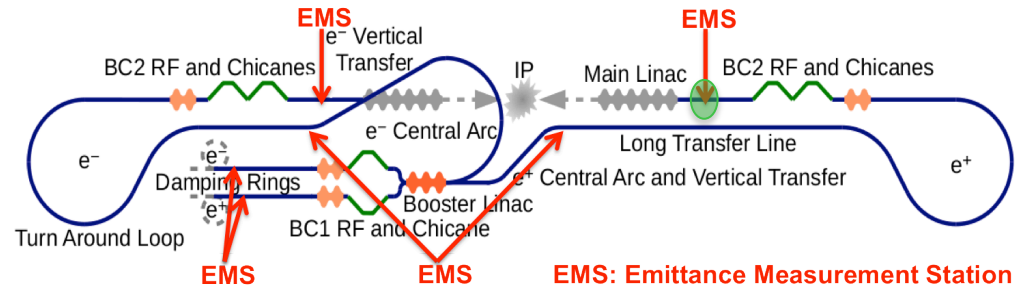
Optics layout  
(2D EMS)



At the end of RTML:

$$\sigma_x \approx 24.6 \mu\text{m} (\beta_x \approx 17.8 \text{ m})$$

$$\sigma_y \approx 4.7 \mu\text{m} (\beta_y \approx 39.8 \text{ m})$$



Material	$\frac{dE}{dz} \left[ \frac{\text{MeV}}{\text{cm}} \right]$	$\Delta T_{inst} \text{ [K]}$	$\Delta T_{fr} \text{ [K]}$
Kapton	3.365	176.11	9240
Al	5.894	194.38	63.662
Be	3.779	85.984	222.28
Ti	9.302	314.44	441.06
W	33.061	1035.9	1059.7

Kapton, Be, Ti and W are below the fracture limit and Al surpasses such limit

## Conclusions and Future Studies

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- Multi-OTR systems can be used to make fast emittance measurements and contribute to the tuning of the RTML of Linear Colliders.
- They are intended to be used in single bunch or low charge mode operation of the machine.
- This system could be very useful during setup and commissioning phases.
- The key point is the selection of suitable materials to make OTR targets, which survive the impact of the pulses.
- According to the thermal calculations presented in this paper, Kapton and Be could be good candidates to be used as OTR radiators in the context of both the ILC and CLIC RTML.



# Conclusions and Future Studies

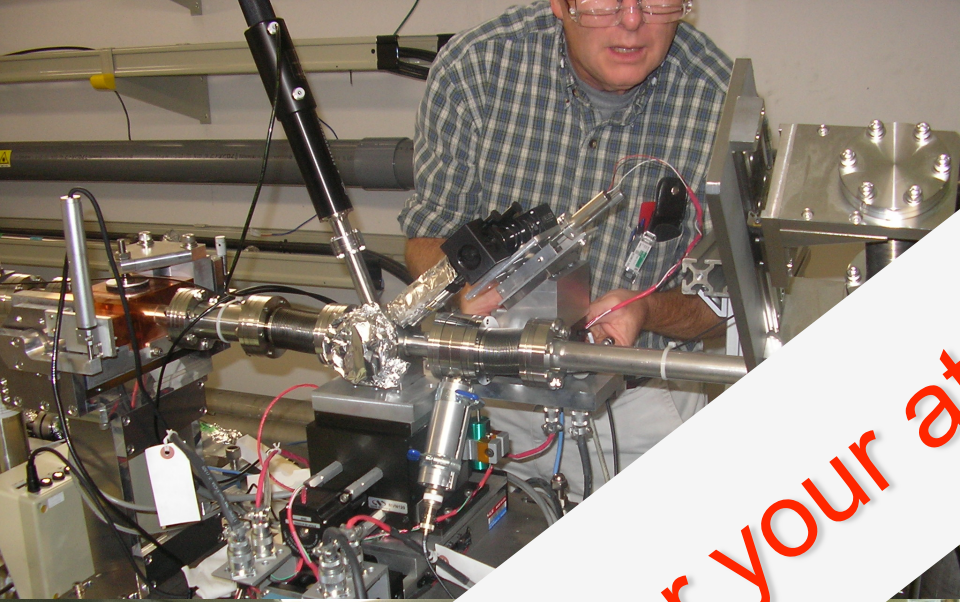
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From the point of view of the system itself:

- Making a turn-key and reliable system giving accurate and consistent measurements:
  - Technical improvements: camera gain and iris control, tilt and optical alignment
  - Issues: Systematic errors from intensity dependence and Wakefields from simultaneous measurements

From the point of view of ILC and CLIC studies:

- The next step will be the study of a optimized system from the point of view of emittance reconstruction.



Thanks for your attention

